# Electronic Information Disclosure Statement

# Microneedle Devices and Methods of Manufacture and Use Thereof

Application:

Confirmation: 4309

Applicant(s): Mark Allen

Docket

BVTP-P04-506

Number: Group Art

Unit:

3763

Examiner:

Thompson, Kathryn L.

( 4320758 or 4664651 or 4671288 or 4703761 or 4775361 or 5035711 or 5147355 or 5599302

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or 5605662 or 5611942 or 5632957 or 5758505 or 5807375 or 5848991 or 5852495 or 5855801 search string:

or 5858188 or 5865786 or 5865796 or 5876675 or 5883211 or 5885211 or 5899880 or 5911223

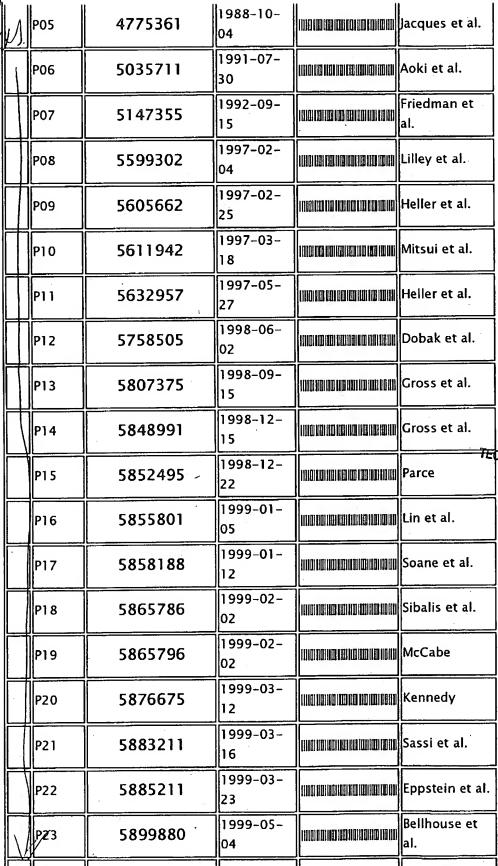
or 5919159 or 20010053891 ).pn.

## US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

	init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
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Note: Applicant is not required to submit a paper copy of cited US Patent Documents

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## Remarks

(Remarks are not for responding to an office action.)

This is Part One of a two-part Information Disclosure Statement. Part Two, citing non-U.S. Patent art, was filed this same day via First Class Mail. While the information and references disclosed in this Information Disclosure Statement may be "material" pursuant to 37 CFR 1.56, it is not intended to constitute an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such. In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents should one or more of the documents be applied against the claims of the present application.

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Examiner Name	Date
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•••				Application Number	10/010723	
11	<b>IFORMATION</b>	I DI	SCLOSURE	Filing Date	December 6, 2001	
S	TATEMENT I	3Y /	APPLICANT	First Named Inventor	Mark G. Allen	
				Art Unit	3763	
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Sheet	1	of	4	Attorney Docket Number	BVTP-P04-506	

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Application Number	10/010723	1	
Filing Date	December 6, 2001	APP	(),
First Named Inventor	Mark G. Allen	"10	EN
Art Unit	3763	COL O	2003
Examiner Name	Thompson, Kathryn L.	CEN	9
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Examiner Initials*	Cite No.1	Foreign Patent Document  Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>3</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>©</sup>
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<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

<sup>&</sup>lt;sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See attached Kinds Codes of USPTO Patent Documents at <a href="https://www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. <sup>3</sup>
Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. <sup>4</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. \*Applicant is to place a check mark here if English language Translation is attached.

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In unless it contains a valid OMB Application Number Filing Date First Named Inventor Art Unit Examiner Name Attorney Docket Number

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of

	Complete if Known
Application Number	10/010723
Filing Date	December 6, 2001
First Named Inventor	Mark G. Allen
Art Unit	3763 "VOLOO
Examiner Name	Thompson, Kathryn L.
Attorney Docket Number	BVTP-P04-506

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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.

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